



**ELECTRONIC COPY**

LG784657145  
Report verification at igi.org



March 28, 2026

IGI Report Number **LG784657145**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **11.54 X 7.43 X 4.56 MM**

**GRADING RESULTS**

Carat Weight **2.53 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

March 28, 2026  
IGI Report Number **LG784657145**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **11.54 X 7.43 X 4.56 MM**

**GRADING RESULTS**

Carat Weight **2.53 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

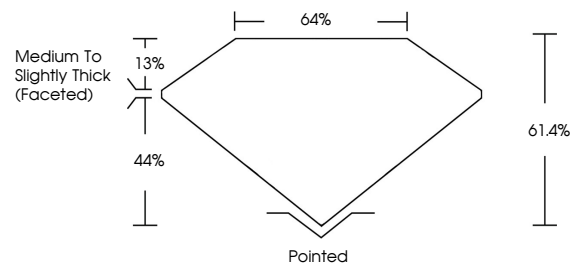
Symmetry **VERY GOOD**

Fluorescence **NONE**

Inscription(s) **IGI LG784657145**

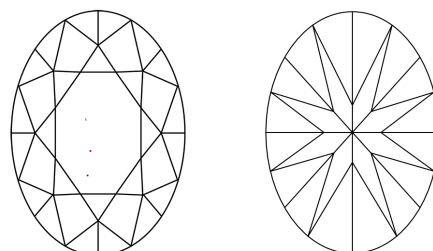
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

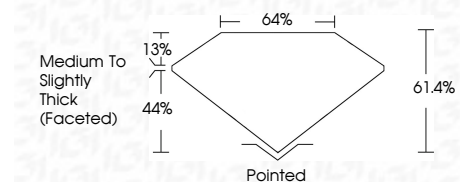
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **VERY GOOD**

Fluorescence **NONE**

Inscription(s) **IGI LG784657145**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



March 28, 2026  
IGI Report No LG784657145  
OVAL BRILLIANT  
11.54 X 7.43 X 4.56 MM  
Carat Weight **2.53 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Depth **61.4%**  
Table **64%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784657145**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa